



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Derderian et al.

Serial No.: 10/787,450

Filed: February 26, 2004

For: METHOD OF FORMING AN INTERFACE FOR A SEMICONDUCTOR

DEVICE (AS AMENDED)

Confirmation No.: 7825

Examiner: J. Maldonado

Group Art Unit: 2823

Attorney Docket No.: 2269-4097.1US

(97-1252.01/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 1, 2006

Leta M. Howard Name (Type/Print)

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following remarks are filed in response to the Examiner's remarks in the Final Office Action mailed July 26, 2006, the three-month shortened statutory period for response to which expires on October 26, 2006. This response is submitted on or before two months from the mailing date of the Final Office Action.

Listing of the Claims begins on page 2 of this paper.

Remarks begin on page 4 of this paper.